

Development and beam observations of an ultra-fast bunch-by-bunch X-ray beam size monitor at SuperKEKB

[arxiv:2607.08205](https://arxiv.org/abs/2607.08205)

R. Nomaru, G. Mitsuka, M. Andrew, K. Yoshihara, C. Driver

The University of Tokyo, KEK, University of Hawaii



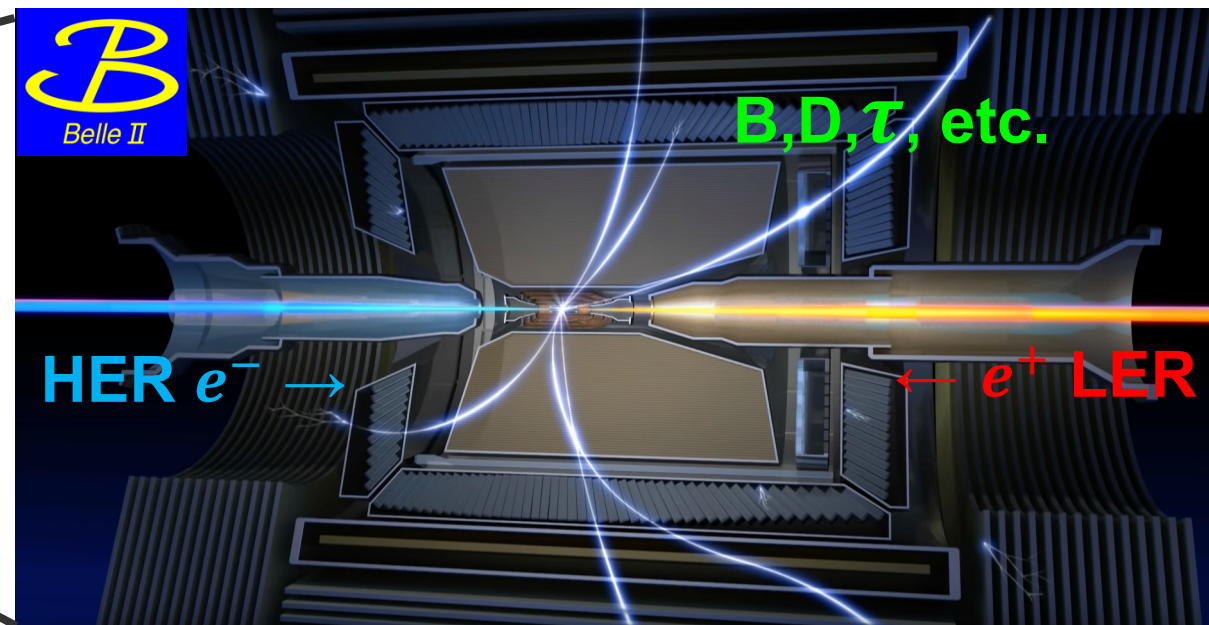
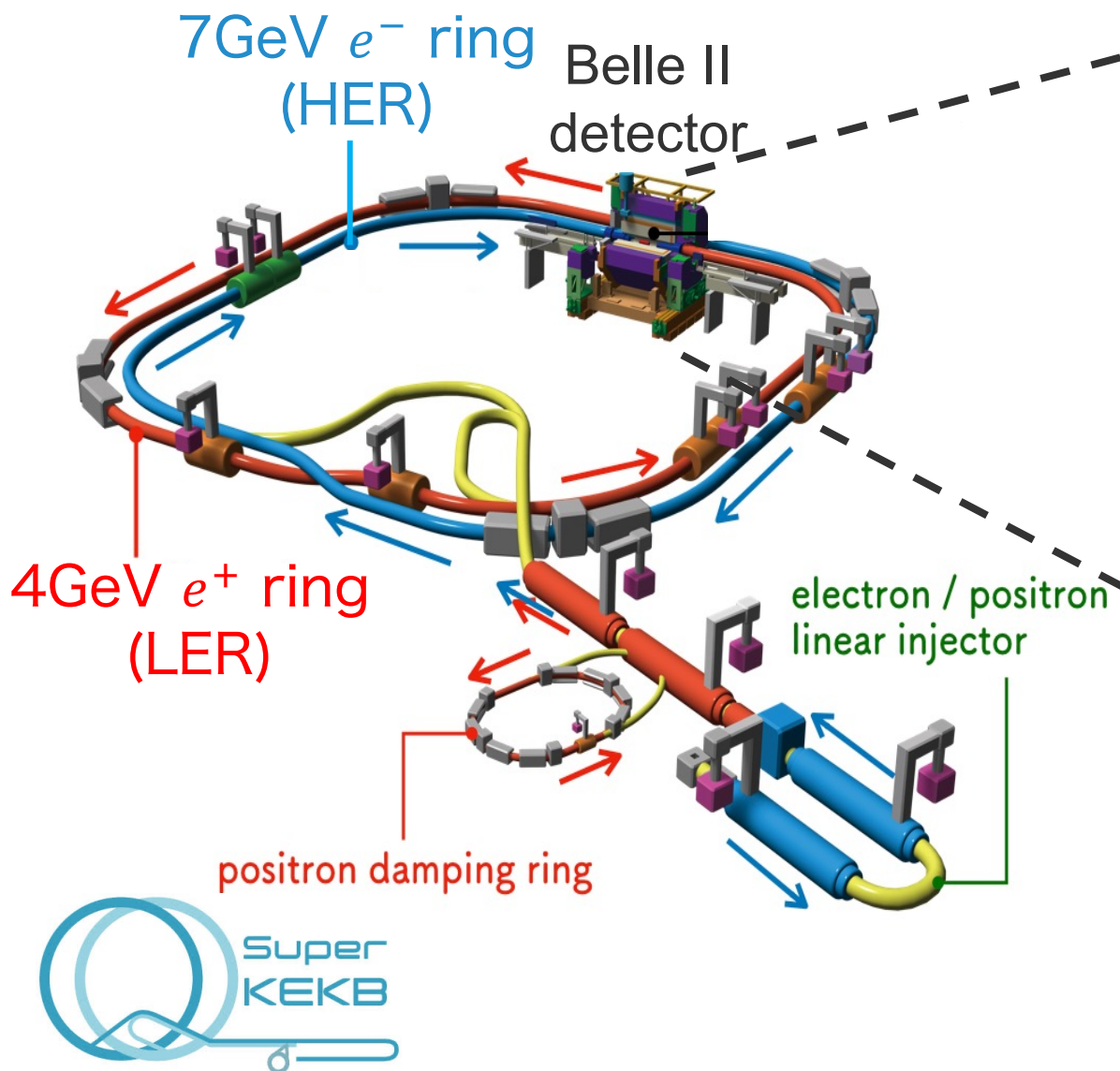
UNIVERSITY
of HAWAII®
MĀNOA



Supported by the U.S.–Japan Science and Technology Cooperation Program

SuperKEKB

High-luminosity electron–positron collider
at KEK in Japan for the search for new physics

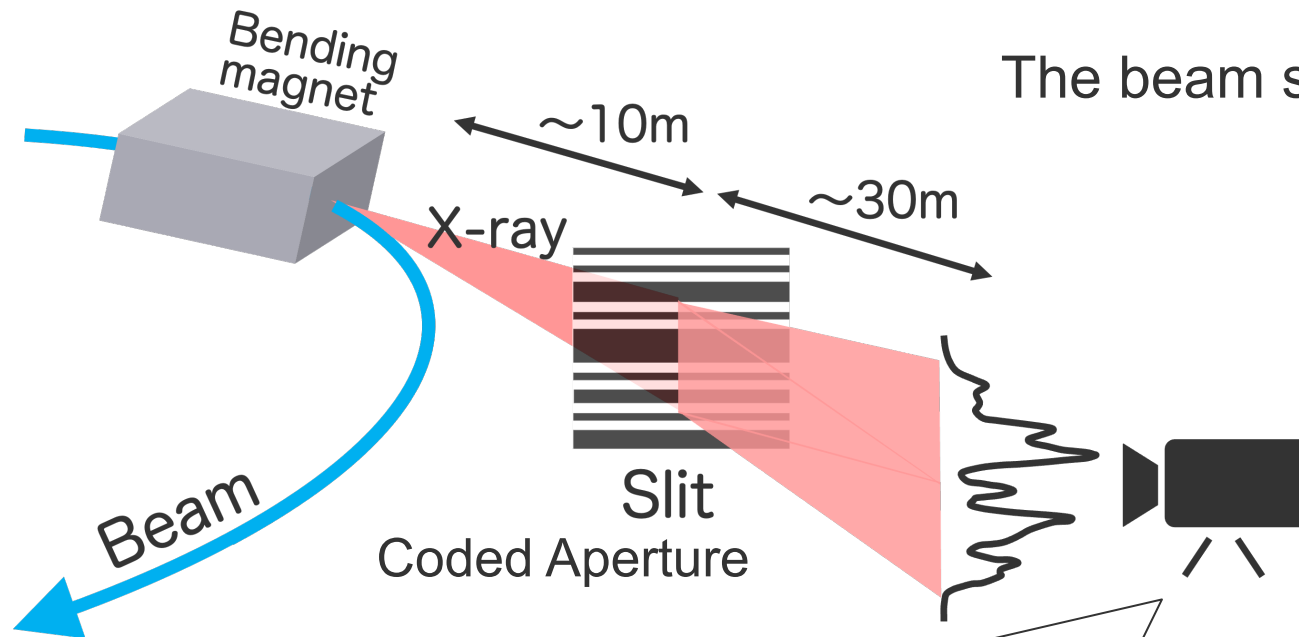


High-current, multi-bunch collisions with
the nano-beam scheme

→ Measurement and understanding of the
beam size are crucial

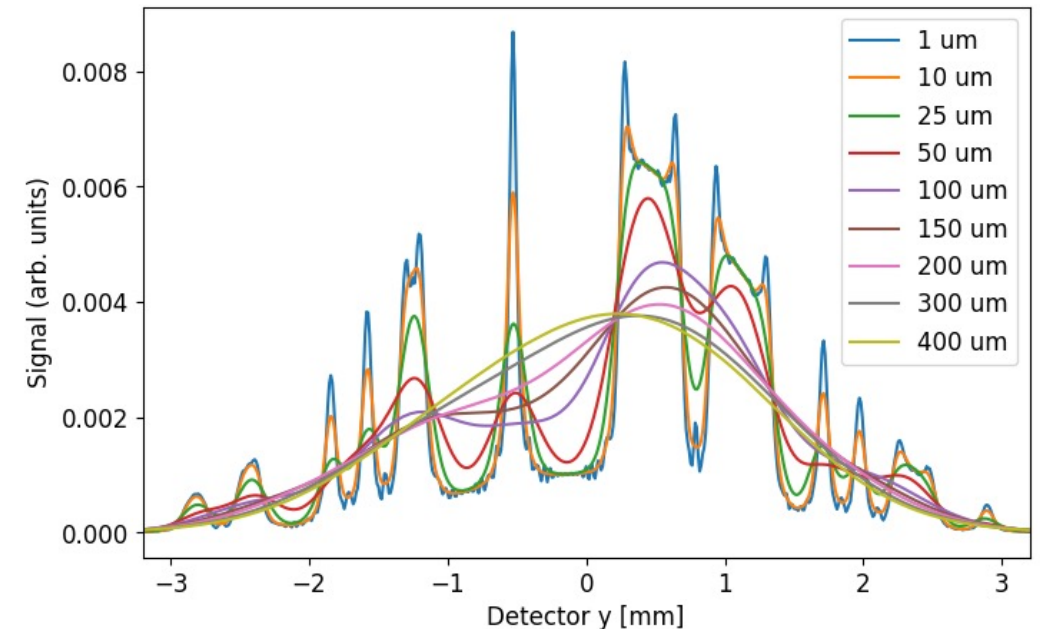
X-ray Beam Size Monitor

Synchrotron X-rays from a bending magnet are imaged through a multi-slit mask. The beam size is obtained by fitting the shape of the X-ray image.



The beam size is extracted from the image sharpness ↓

X-ray Images corresponding to different vertical beam sizes



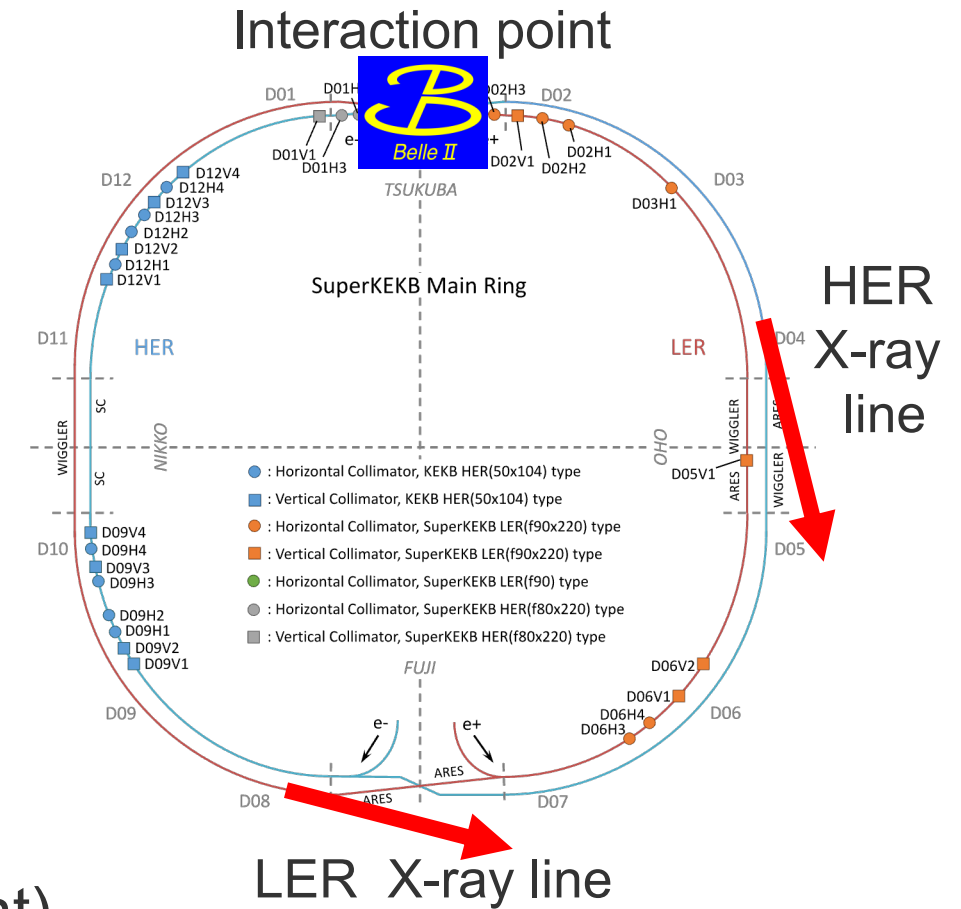
Conventional: scintillator + CMOS camera

This project:

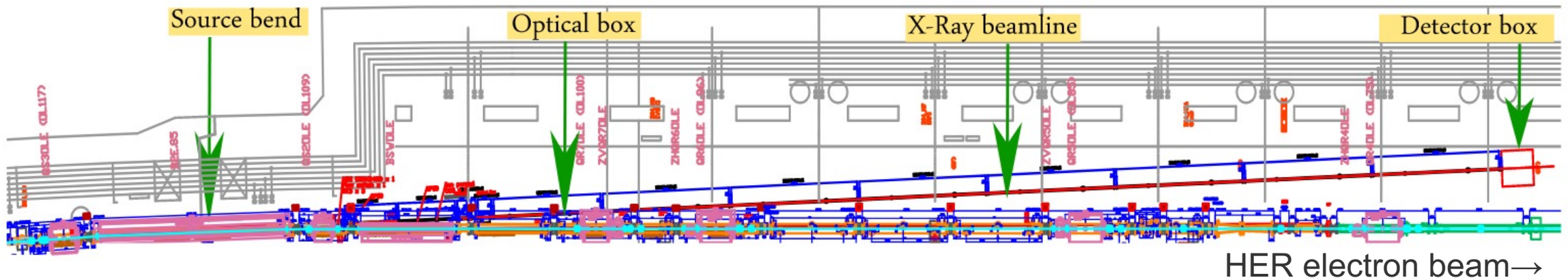
silicon sensor for high-speed sampling

X-ray Beamline

- One X-ray extraction line is installed for each ring: HER (electron) and LER (positron).
- Synchrotron X-rays are extracted tangentially from the last bending magnet in the arc section.



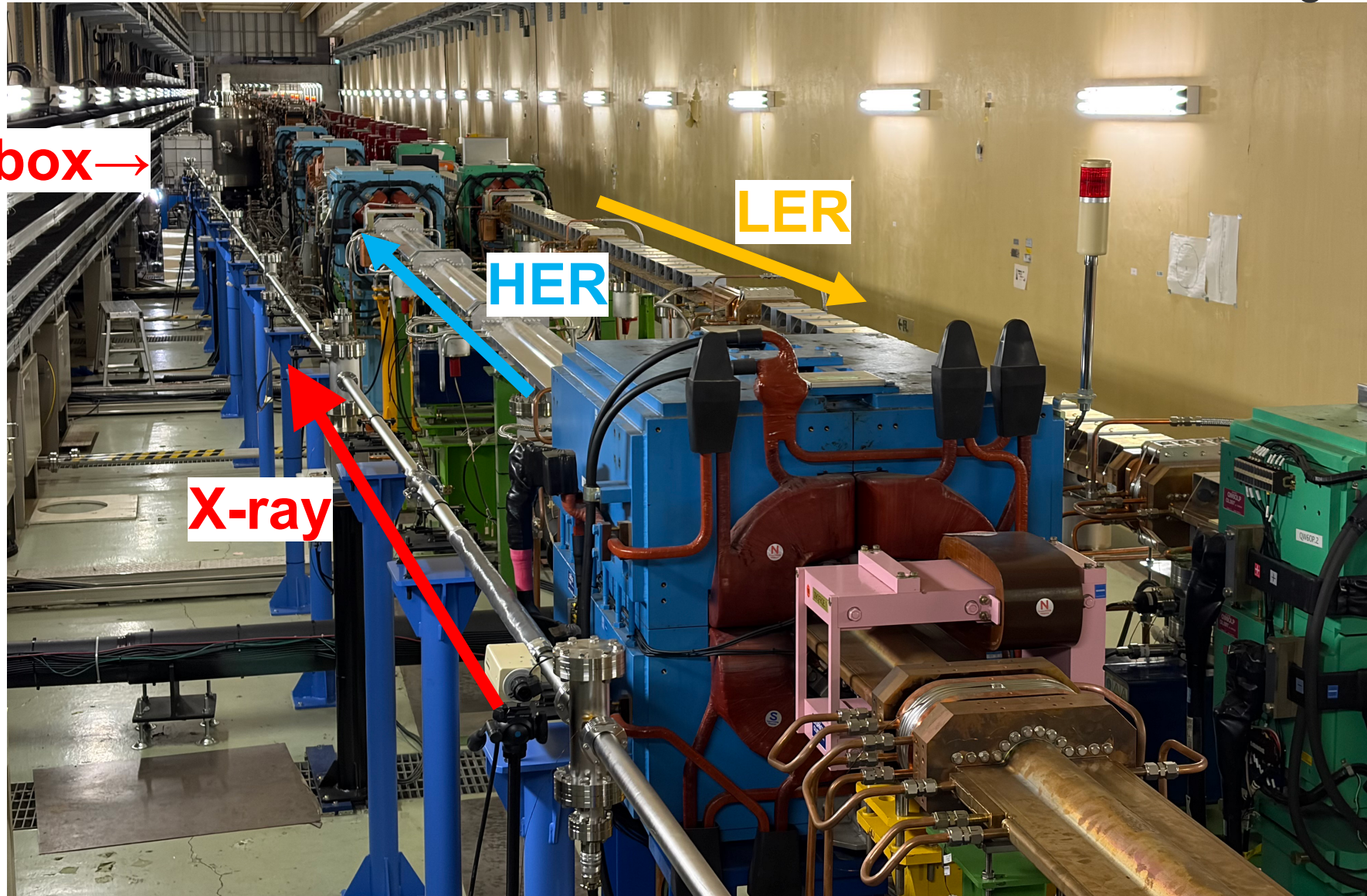
HER X-ray line ($\beta_y = 28$ m at the SR source point)



X-ray Beamline

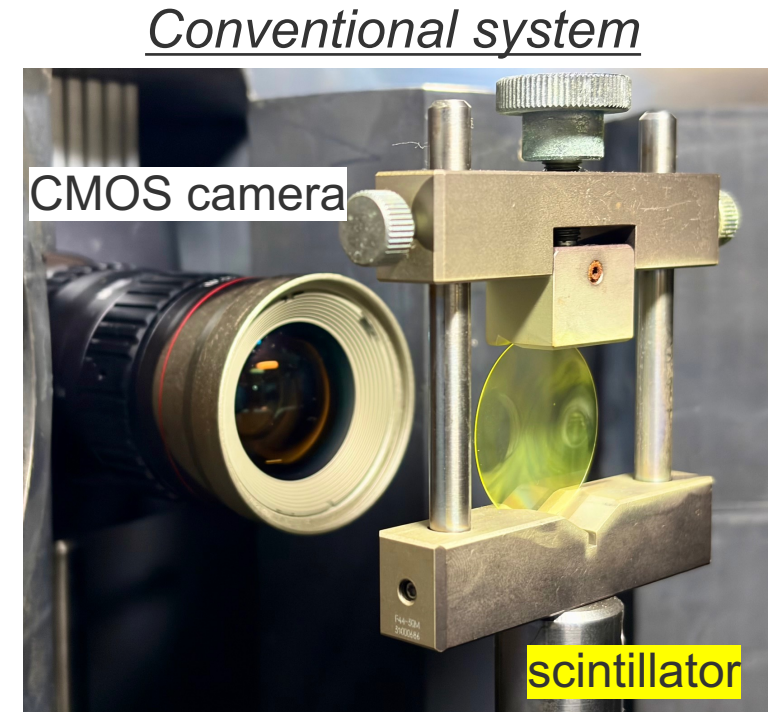
Oho straight section

Detector box→



Motivation

- Conventional X-ray beam size monitor
 - X-rays $\rightarrow$ scintillator $\rightarrow$ CMOS camera
 - Exposure time: $>$ tens of μ s
 - Frame rate: $<$ 100 Hz
- This is too slow to observe fast beam dynamics
 - Measures the beam size averaged over many bunches (bunch spacing ~ 4 ns)
 - Cannot resolve beam-size variation along the bunch train (electron cloud, fast-ion, sudden beam loss, etc.)



Our approach

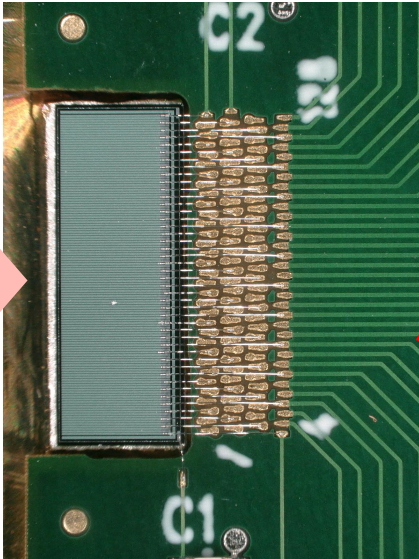
Silicon strip sensor for fast bunch-by-bunch beam size measurements

Bunch-by-Bunch Beam Size Monitor (SiXRM)

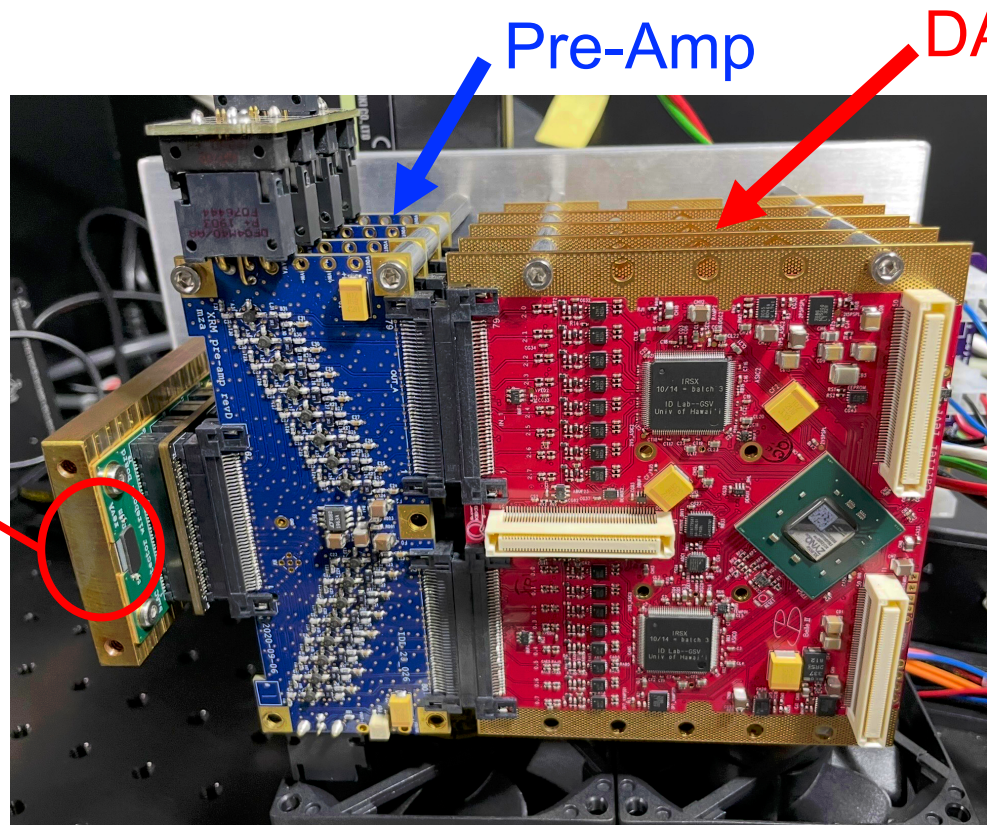
- 128-ch silicon strip sensor + preamplifier + DAQ (Hawaii × KEK collaboration)
- 2.7 GSa/s sampling enables bunch-by-bunch beam size measurement
- Vertical (Y) beam size only
- ~20 s to acquire one full turn

128ch Si strip sensor

X-ray



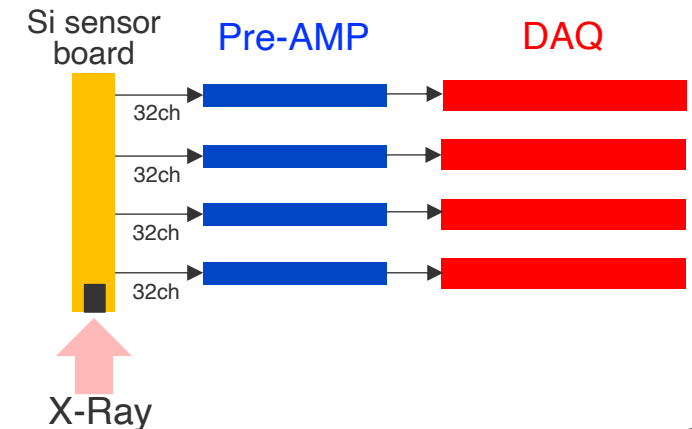
42 channels currently used due to wire-bonding limitations



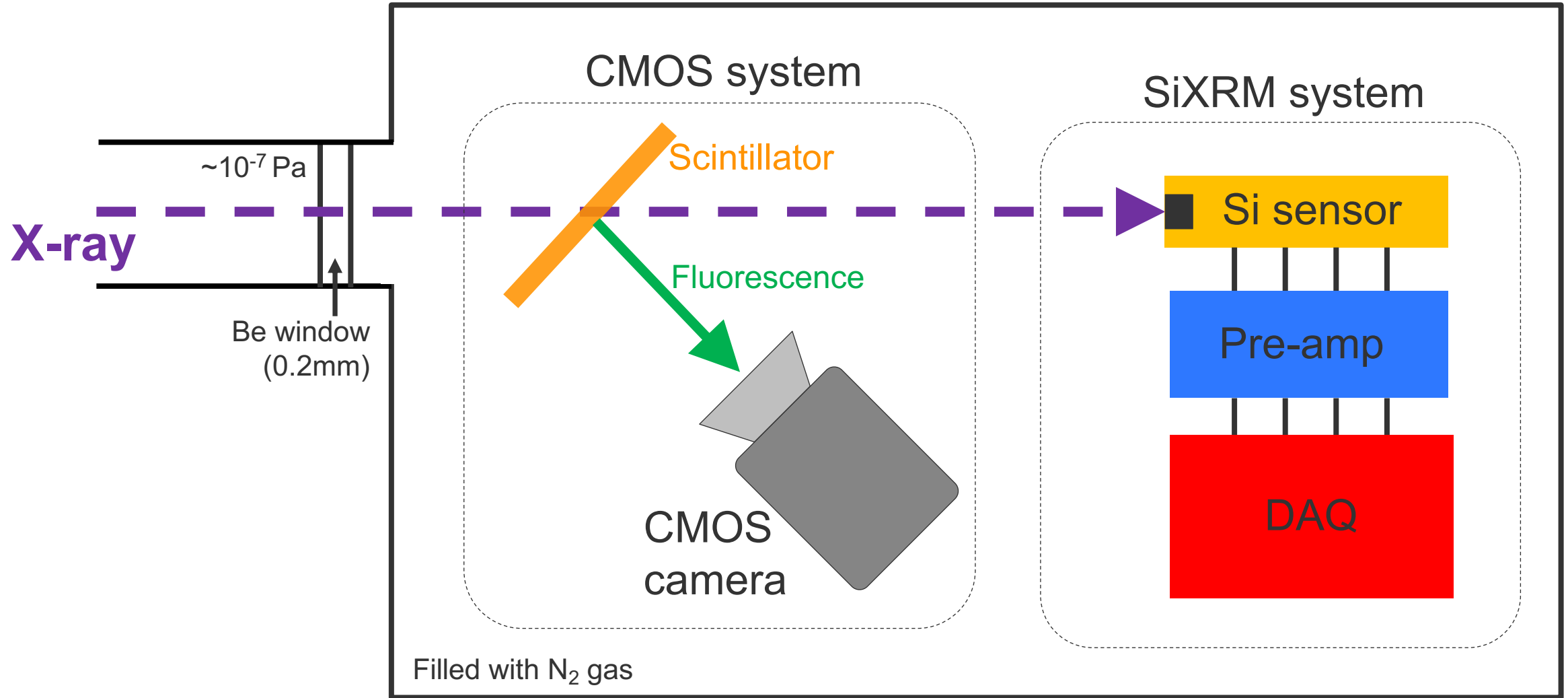
DAQ(ADC+FPGA)

Belle II TOP
SCROD+Carrier
boardstacks

Top View



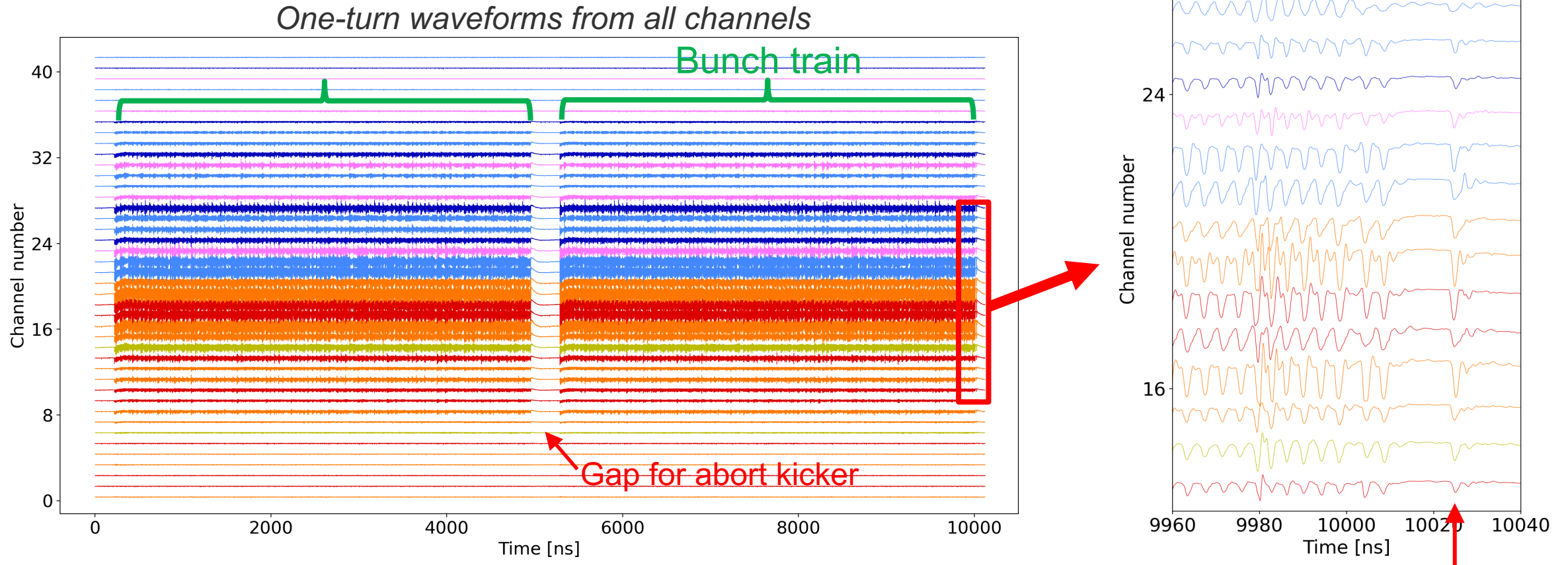
Detector Box



X-rays can be measured simultaneously with the CMOS camera and SiXRM.

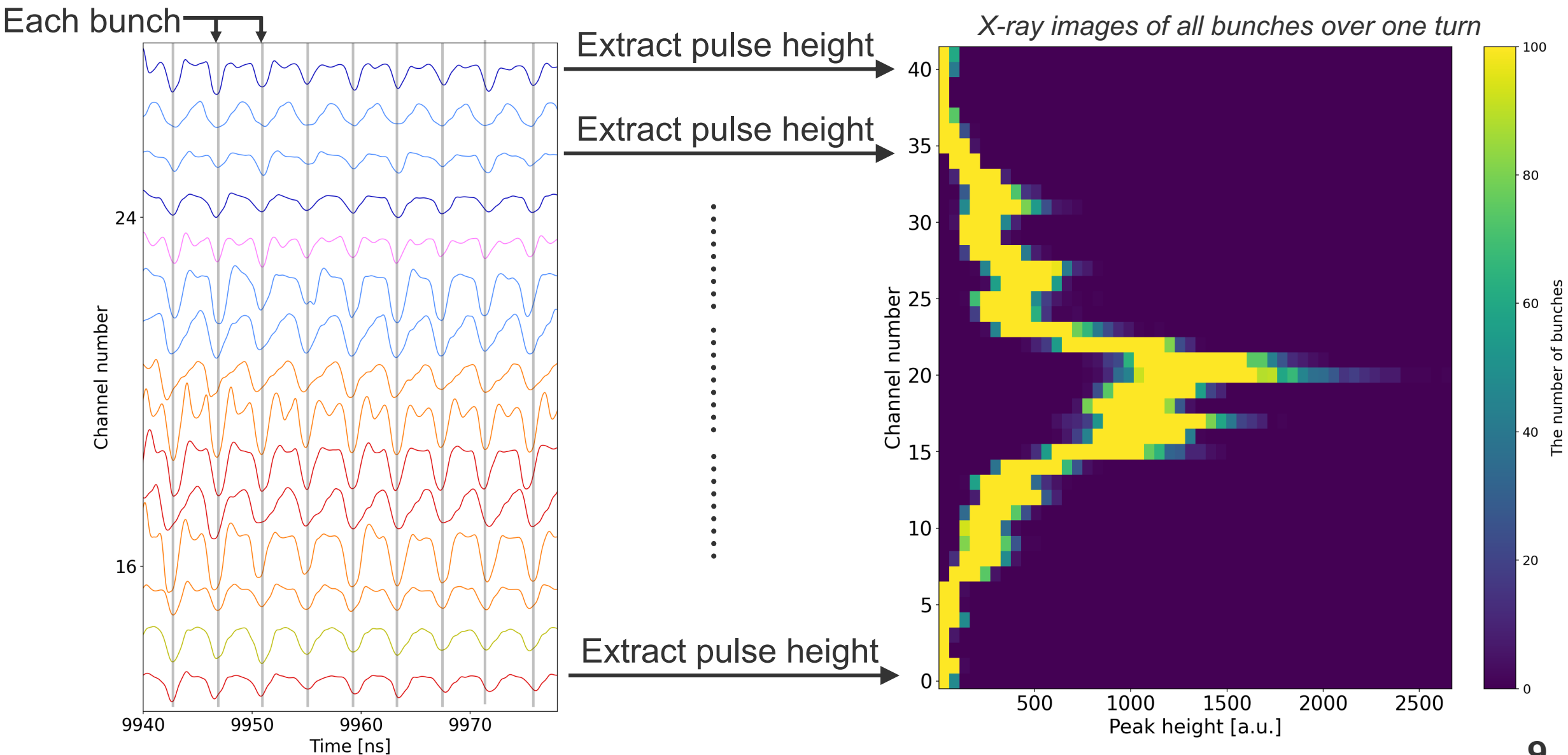
Beam Observation in the HER

2026/02/02 09:02 Beam current ~800mA



Record a 12-RF-bucket waveform window and repeat over all buckets
Concatenate the windows to reconstruct one full turn
Acquisition time: ~50 ms/window, ~20 s/turn

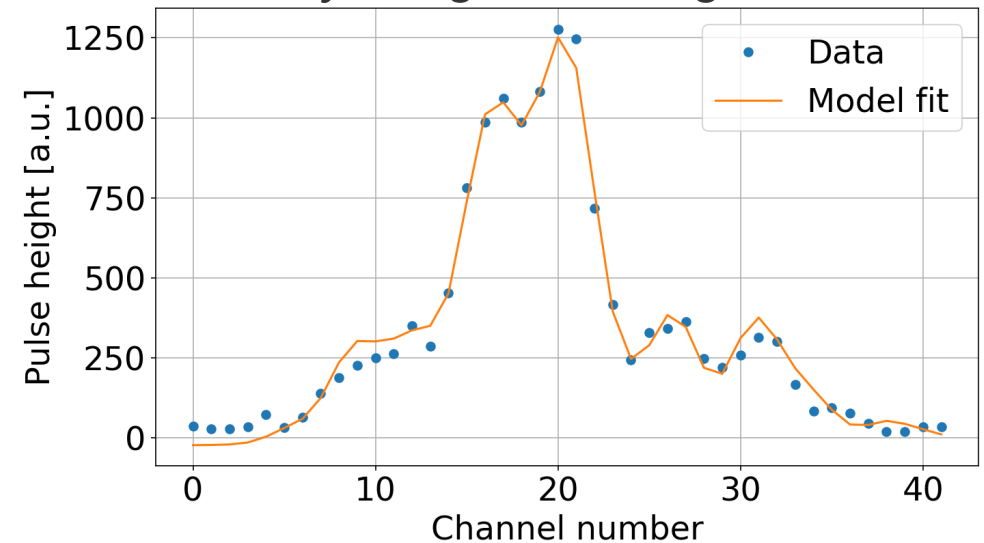
X-ray Image Reconstruction



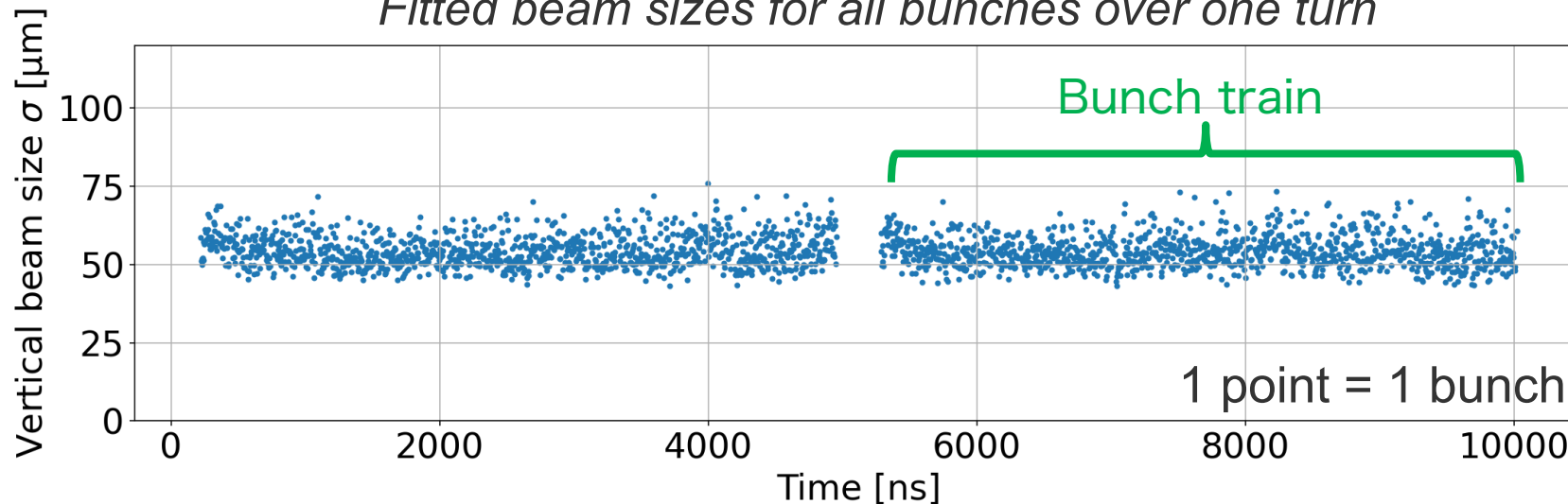
Beam Size Extraction

- Perform a fit for the reconstructed X-ray image of each bunch.
- Fit each image with simulated templates for various beam sizes and positions using the least-squares method.

X-ray image of a single bunch



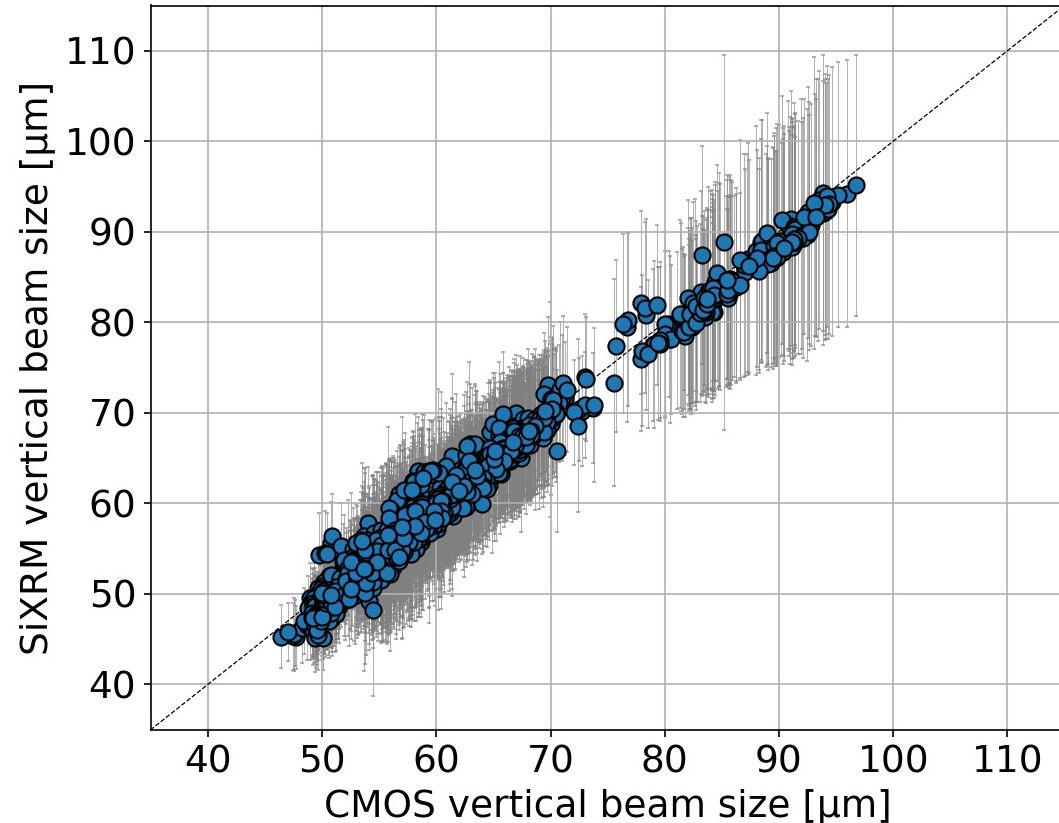
Fitted beam sizes for all bunches over one turn



First successful
bunch-by-bunch
beam size measurement
at SuperKEKB using
a silicon sensor

Comparison with the CMOS System

- Compare SiXRM with the conventional CMOS measurement (multi-bunch average)



2,429 measurements at HER (Nov. 2025 – Feb. 2026)

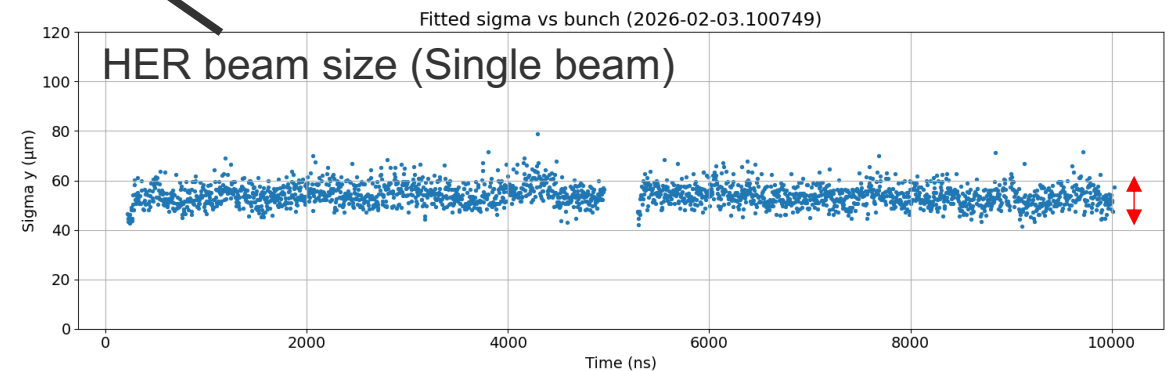
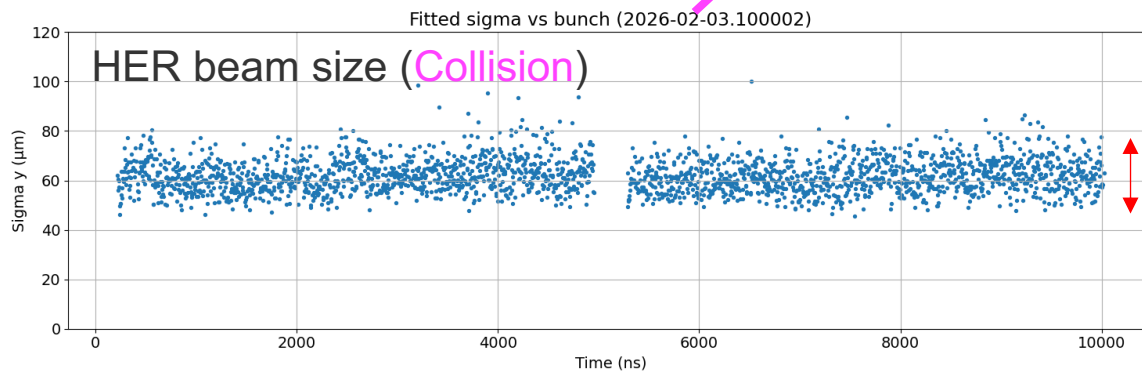
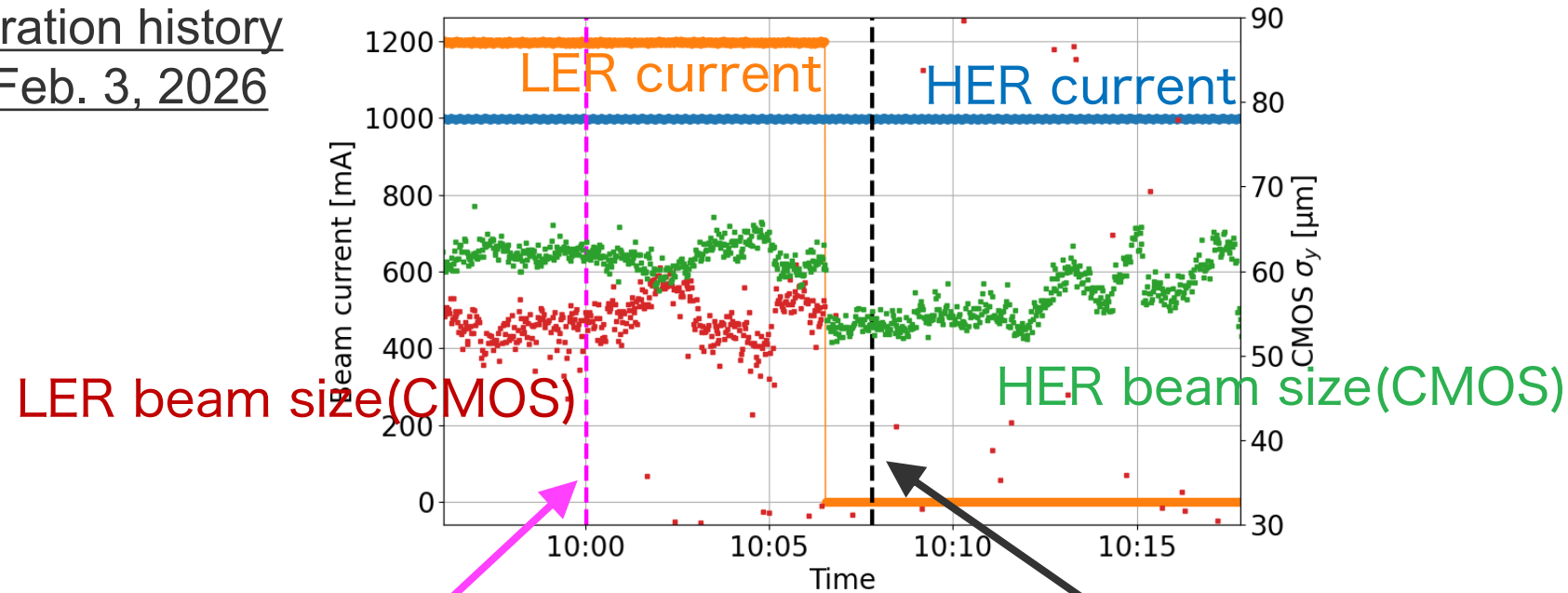
- One point = one measurement (one turn)
- SiXRM beam size (vertical axis)
 - = mean over all bunches in one turn
- Error bars
 - = bunch-to-bunch standard deviation

※ CMOS camera system resolution: $\sim 1 \mu\text{m}$ (1σ std.)

Good agreement with the CMOS system confirms the SiXRM performance

Observation Example – Collision vs. Single-Beam

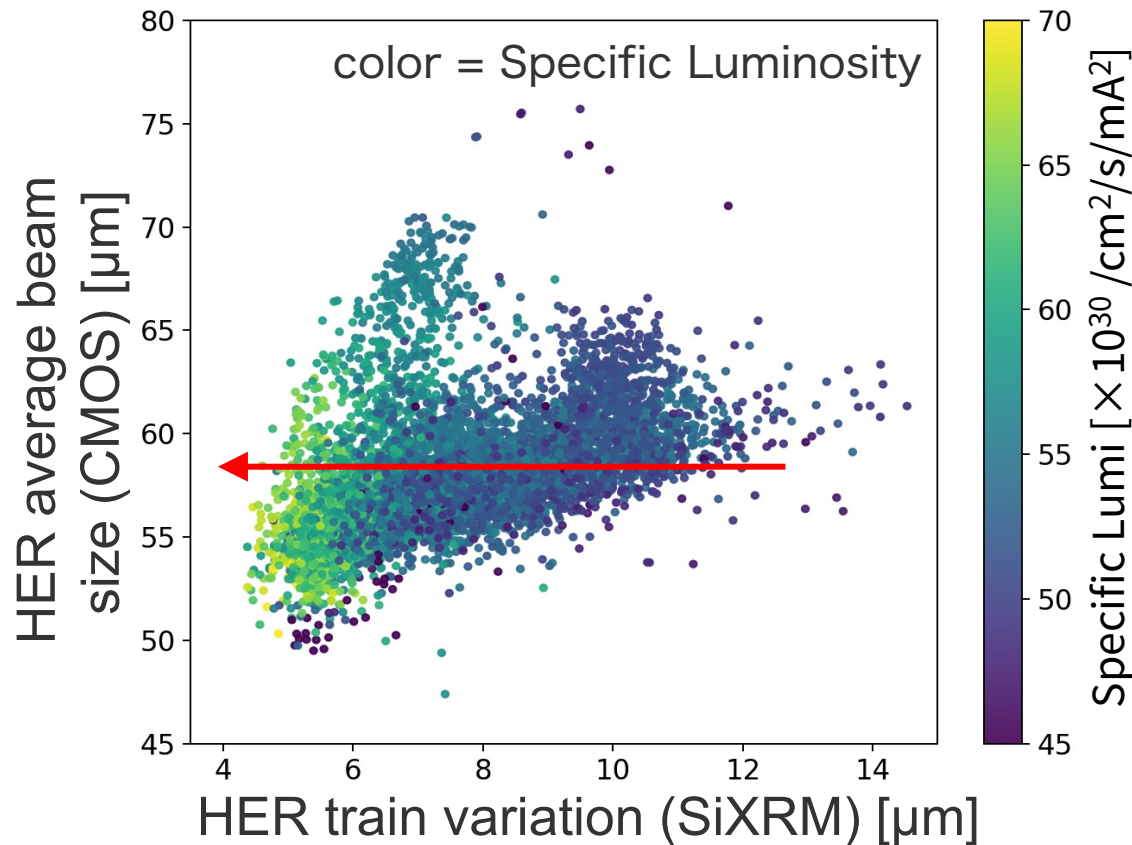
Operation history
on Feb. 3, 2026



- Larger bunch-to-bunch beam-size variation during collision
- Variation quantified by the standard deviation σ over all bunches in one turn

Beam-Size Variation Along the Bunch Train

*Train variation (SiXRM) vs.
average HER beam size (CMOS)*



Specific luminosity = luminosity normalized
by the number of bunches and bunch currents

When the average beam size increases ...

The bunch train not only grows overall,
but also shows larger bunch-to-bunch
beam-size variation.

New insight from SiXRM

Even at similar average beam size,
smaller train variation corresponds
to higher specific luminosity.

SiXRM Upgrade Plan

- Current limitations
 - Only 6 bunches per shot → cannot capture many bunches / multiple turns
 - 2.7 GSa/s sampling is not synchronized with the 509 MHz RF
 - ADC electronics near the sensor are exposed to X-ray radiation
- Upgrade
 - Replace the readout with AMD/Xilinx RFSoc
 - RFSoc = High-speed multi-channel ADC + FPGA + CPU
 - Use 3 × ZCU216 boards
 - 16-ch, 14-bit, 2.5 GSa/s ADC per board
 - Keep only the preamplifier near the sensor
 - Transmit signals by cable and place the RFSoc behind shielding
 - Protect electronics from radiation

RFSoc ZCU216 board



See **WEP016** for upgrade details.

Summary

- Developed and installed SiXRM in the electron ring, achieving the first successful X-ray bunch-by-bunch beam size measurement at SuperKEKB.
- Good agreement with the conventional CMOS system validates the measurement
- Bunch-to-bunch beam-size variation is correlated with collision conditions and luminosity.
- Analyses are ongoing to understand beam-beam effects and beam instabilities.
- A readout upgrade is in progress, aiming for full bunch-by-bunch and turn-by-turn measurements.

Thank you for your attention.